



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/678,513
Filing Date October 3, 2003
Inventor..... Werner Juengling
Assignee..... Micron Technology, Inc.
Group Art Unit..... 2823
Examiner Brook Kebede
Attorney's Docket No. MI22-2391
Customer No. 021567
Title: Semiconductor Processing Methods Of Forming A Contact Opening To A
Conductive Line and Methods of Forming Substrate Active Area Source/Drain
Regions

RESPONSE TO JUNE 26, 2006 OFFICE ACTION

To: Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

From: D. Brent Kenady
Tel. 509-624-4276; Fax 509-838-3424
Wells St. John P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3817

Responsive to the Office Action dated June 26, 2006, Applicant amends and
remarks as follows:

AMENDMENTS

Underlines indicate insertions and ~~strikeouts~~ indicate deletions.

10/30/2006 JBALINAN 00000028 10678513

02 FC:1201 400.00 OP
03 FC:1202 450.00 OP

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